



PATENT APPLICATION

RESPONSE UNDER 37 CFR §1.116

EXPEDITED PROCEDURE

TECHNOLOGY CENTER ART UNIT 2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Group Art Unit: 2823

Application No.: 09/857,803

Examiner: M. Estrada

Filed: June 11, 2001

Docket No.: 109725

For: METHOD FOR PRODUCING SOI WAFER AND SOI WAFER

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the January 16, 2004 Office Action, reconsideration of the rejection is respectfully requested in light of the following remarks.

Claims 1-3 and 6-8 are pending in this application, claims 6-8 having been withdrawn from consideration as directed to a non-elected invention. Applicants respectfully submit that the remarks below regarding each of claims 1-3 apply equally to their respective dependent claims 6-8. Thus, Applicants respectfully submit that, upon allowance of claims 1-3, claims 6-8 should be rejoined and allowed.

Claims 1 and 2 are rejected under 35 U.S.C. §103(a) as allegedly unpatentable over the combination of Japanese Patent JP-10275905 to Yamamoto and U.S. Patent Application Publication US 2002/0127820 to Sato. The Office Action also rejects claims 3-5 under 35 U.S.C. §103(a) over the combination of Yamamoto and Sato as applied to claims 1 and 2,